

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Ino et al.

ATTORNEY DOCKET NO: *S. Steven*  
*2/9*  
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09792909-4645

SERIAL NO.

GROUP ART UNIT:

FILING DATE:

EXAMINER:

INVENTION: "PROCESS OF FABRICATING THIN  
FILM SEMICONDUCTOR DEVICE"

which is a Divisional of copending Application of the following U.S. Application

APPLICANT: Ino et al.

OLD ATTORNEY DOCKET NO:

P97,0916

NEW ATTORNEY DOCKET NO:

09792909-3529

SERIAL NO. 08/878,588

GROUP ART UNIT: 2823

FILING DATE: June 19, 1997

EXAMINER: S. Hawranek

INVENTION: "PROCESS OF FABRICATING THIN  
FILM SEMICONDUCTOR DEVICE"

**PRELIMINARY AMENDMENT**

Asst. Commissioner of Patents  
Washington, D.C. 20231

Sir:

Please enter the following amendment prior to examination of the above-identified patent application.

**IN THE SPECIFICATION**

Between the title and the heading "Background of the Invention" insert the following:

**--RELATED APPLICATION DATA**

91  
This application is a divisional of copending application Serial No. 08/878,588 filed June 19, 1997, New Attorney Docket No. 09792909-3529, Old Attorney Docket No. P97,0916. The present and foregoing applications claim priority to Japanese application No.